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Docket No. 0819

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Increase at Application of

Shinichi IMAI

Serial No. 09/960,575

Filed: September 24, 2001

For: SEMICONDUCTOR DEVICE

AND METHOD FOR

PRODUCING THE SAME

## CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with The United States Postal Service with sufficient postage as First Class Mail in an envelope addressed to: Commissioner for Patents, Washington, D.C. 20231, on June 4, 2002

Attention: Office of Public Records

REQUEST FOR CORRECTED NOTICE OF PUBLICATION OF APPLICATION

Honorable Commissioner of Patents

Washington, D.C. 20231

Sir:

The Notice of Publication of Application received in the above-identified application has errors thereon due to Patent Office error as shown in red on the attached copy.

In view of the above, it is requested that a Corrected Notice of Publication of Application be issued.

Respectfully submitted,

Donald R. Studebaker

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ATTY. DOCKET NO. FIRST NAMED APPLICANT APPLICATION NUMBER ESLING DATE 0819-0651 Shinichi Imai 09/960,575 **CONFIRMATION NO. 7295** 22204 000000008144589\* NIXON PEABODY, LLP 8180 GREENSBORO DRIVE SUITE 800 MCLEAN, VA 22102 GINALLY Producina Title: Semiconductor device and method for fabricating the same Publication No. US-2002-0058390-A1 Publication Date: 05/16/2002

Date Mailed: 05/17/2002

## NOTICE OF PUBLICATION OF APPLICATION

The above-identified application will be electronically published as a patent application publication pursuant to 37 CFR 1.211, et seq. The patent application publication number and publication date are set forth above.

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